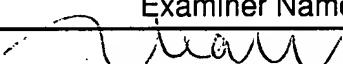


ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

| Title of Invention | METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND POLYCRYSTAL ITO ELECTRODE | | | | | | |
|---|---|------------|------------|--------------|------|-------|----------|
| Application Number: | 10/711864 | | | | | | |
| Confirmation Number: | 10/11/04 | | | | | | |
| First Named Applicant: | Fang-An Shu | | | | | | |
| Attorney Docket Number: | 14150-US-PA | | | | | | |
| Art Unit: | | | | | | | |
| Examiner: | | | | | | | |
| Search string: | (6448158 or 6218310).pn | | | | | | |
| US Patent Documents | | | | | | | |
| Note: Applicant is not required to submit a paper copy of cited US Patent Documents | | | | | | | |
| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
| TN | 1 | 6448158 | 2002-09-10 | Chih-Yu Peng | B2 | 438 | 487 |
| TN | 2 | 6218310 | 2001-04-17 | Lewis Shen | B1 | 438 | 714 |
| Signature | | | | | | | |
| Examiner Name | | | | Date | | | |
|  | | | | 9/14/05 | | | |